

Notice of References Cited	Application/Control No. 10/724,577	Applicant(s)/Patent Under Reexamination MIURA ET AL.	
	Examiner Barbara Summons	Art Unit 2817	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,767,749	07-2004	Kub et al.	438/3
	B	US-6,445,265	09-2002	Wright, Peter	333/193
	C	US-6,259,186	07-2001	Shibata et al.	310/313A
	D	US-6,198,197	03-2001	Yamanouchi et al.	310/313R
	E	US-4,006,438	02-1977	Bennett, Glenn Edward	333/196
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	JP 51-77154	11-1982	Japan	Mitsubishi Electric Corp.	-----
	O	JP 6-56592	03-1994	Japan	Shibata et al.	427/585
	P	JP 2001-285019	10-2001	Japan	Heiko et al.	-----
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Y. Shibata et al.; "Piezoelectric LiNbO3 and LiTaO3 Films for SAW Device Applications", 1996 IEEE Ultrasonics Symposium, vol. 1, November 1996, pp. 247-254.
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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